

SFB 917
Nanoswitches

JARA|FIT



Redox-based switching mechanisms in memristive devices studied by synchrotron-based spectromicroscopy

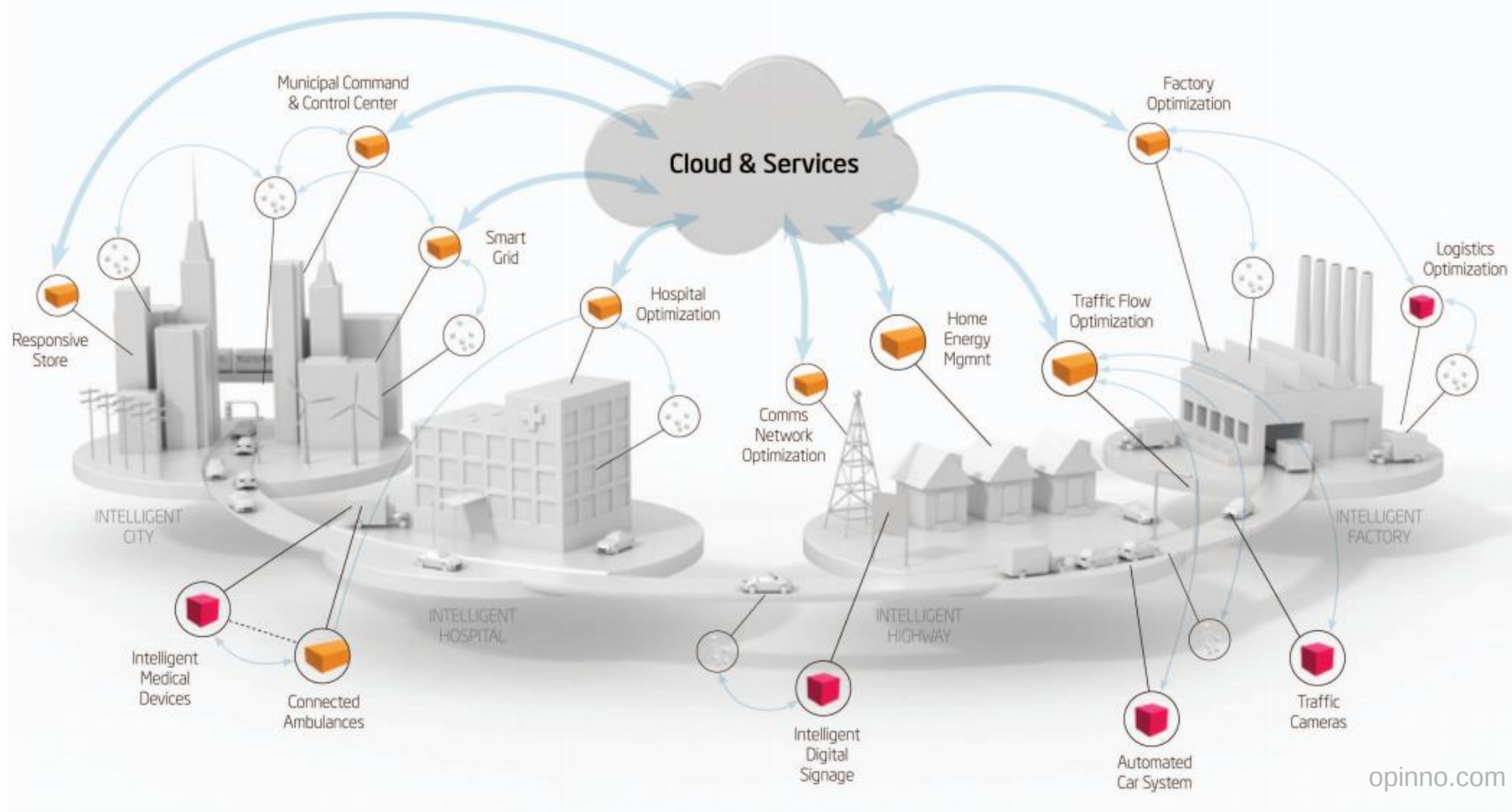
C. Bäumer¹, C. Schmitz², C. M. Schneider²,
R. Waser^{1,3} & R. Dittmann¹

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³*Institute of Electronic Materials (IWE-2), RWTH Aachen, Germany*

1. **Motivation:** Memristive devices for nonvolatile memory
2. ***Operando* spectromicroscopy:**
Comprehensive understanding of memristive processes: oxygen vacancy motion
3. **Post mortem spectromicroscopy:**
Design rules to prevent retention failure
4. **Beam-sample interaction**
5. **Conclusion**



Technological revolution requires new concepts in data storage and mobile computing

Flash



<https://en.wikipedia.org/>

- non-volatile
- slow
- switching time: μs
- high voltage required

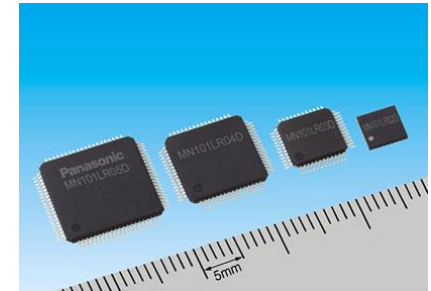
DRAM



<https://en.wikipedia.org/>

- volatile
- fast
- switching time: ns
- refresh power and time

ReRAM



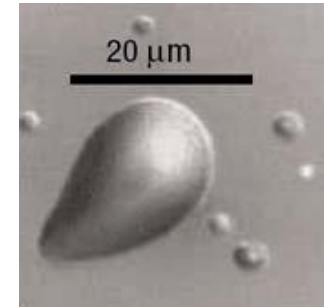
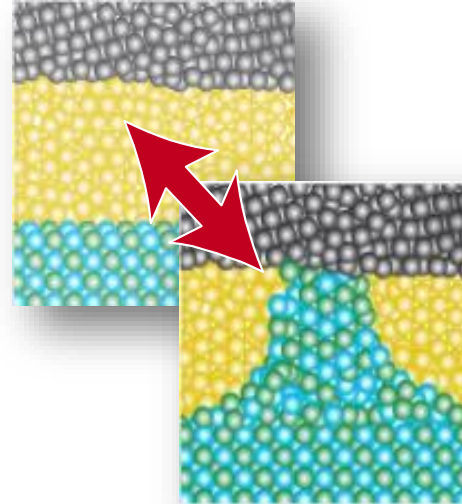
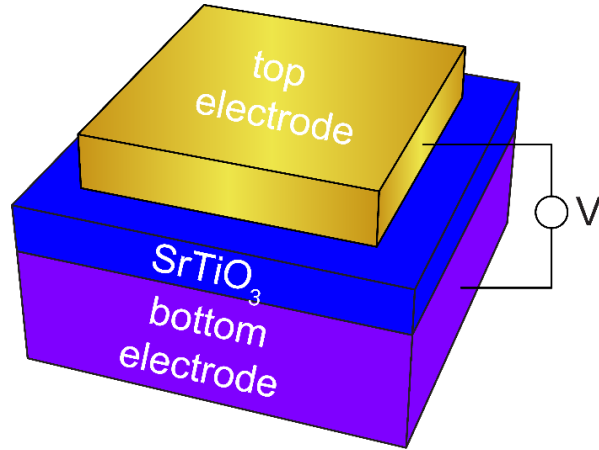
<http://news.panasonic.com/>

- non-volatile
- fast
- switching time: ns
- **Complex mechanisms**

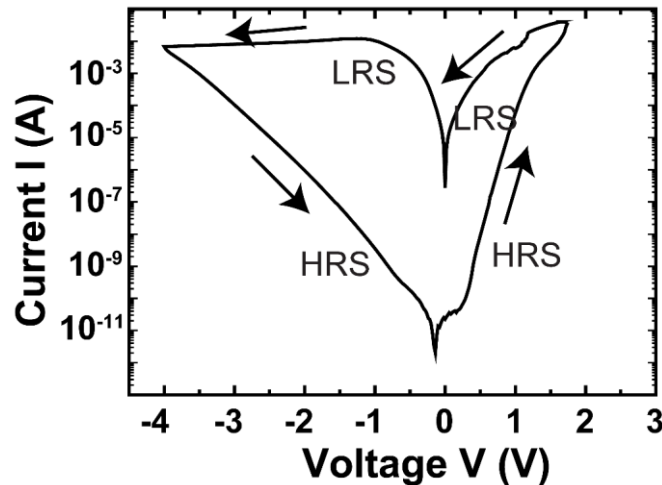
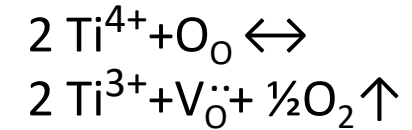
Kent, *Nat. Nanotech.* **10** (2015)

Szot *et al.*, *Nat. Mater.* **5** (2006)
Waser *et al.*, *Nat. Mater.* **6** (2007)
Waser *et al.*, *Adv. Mater.* **21** (2009)

Wong *et al.*, *Proceedings of the IEEE* **100** (2012)
Cooper *et al.*, *Adv. Mater.* (accepted, 2017)



Oxygen evolution underneath the anode:

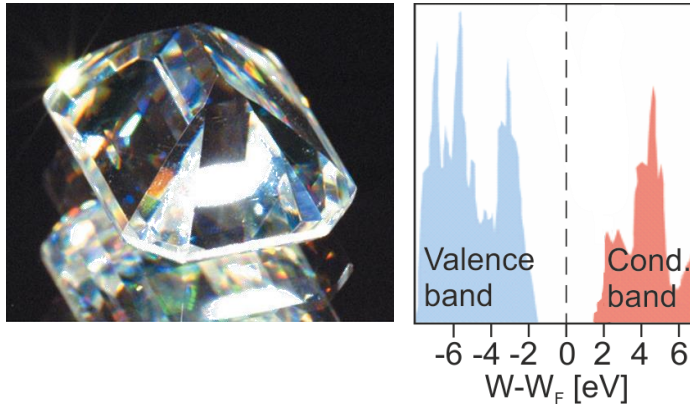


- Oxygen vacancy generation and redistribution under applied field → local redox reaction
- Spatial confinement: filamentary switching
- ? Quantitative details
- ? Impact on electronic transport
- **Spectromicroscopic quantification mandatory**

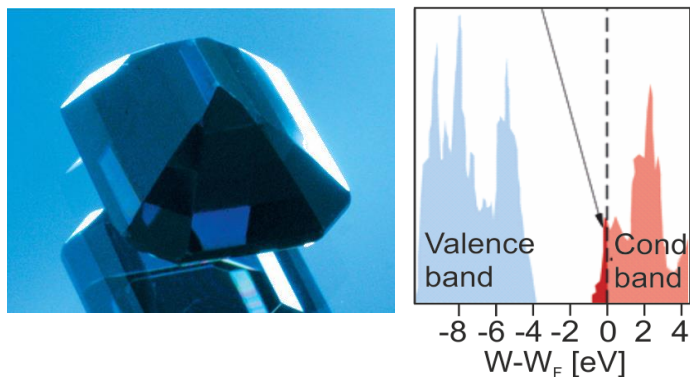
Baeumer *et al.*, *Nat. Commun.* **6** (2015)

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- Stoichiometric SrTiO_3 :
transparent, insulating

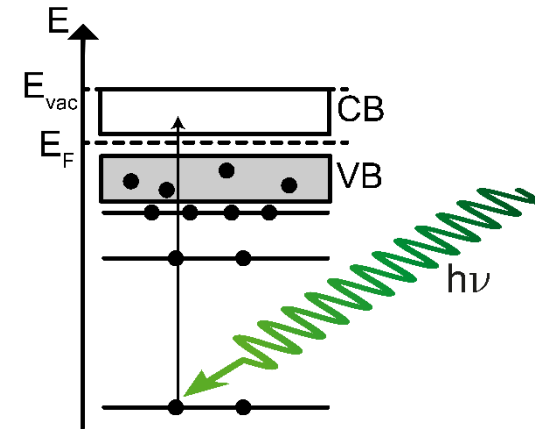


- Oxygen deficient $\text{SrTiO}_{3-\delta}$:
opaque, conducting

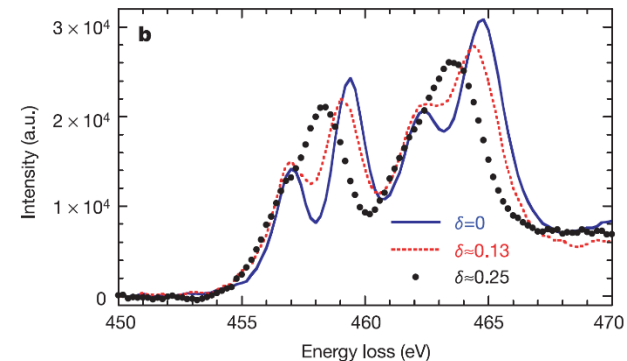


Waser, *Adv. Mater.* **21** (2009)

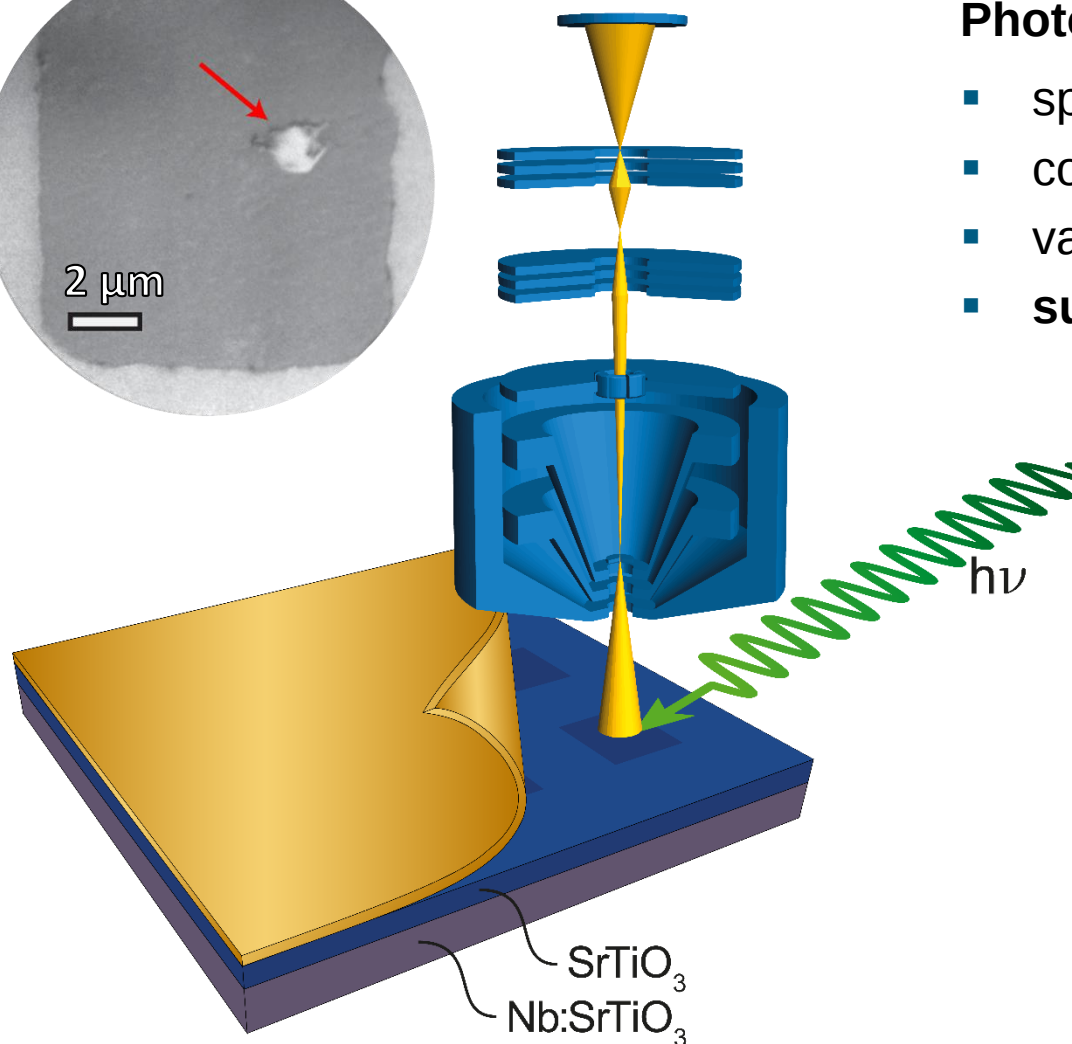
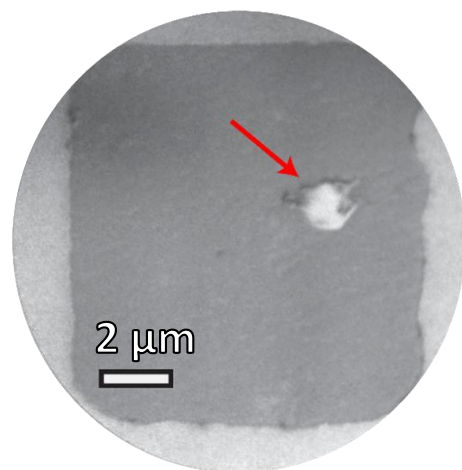
- X-ray absorption spectroscopy, EELS



- oxygen vacancies cause significant spectral changes

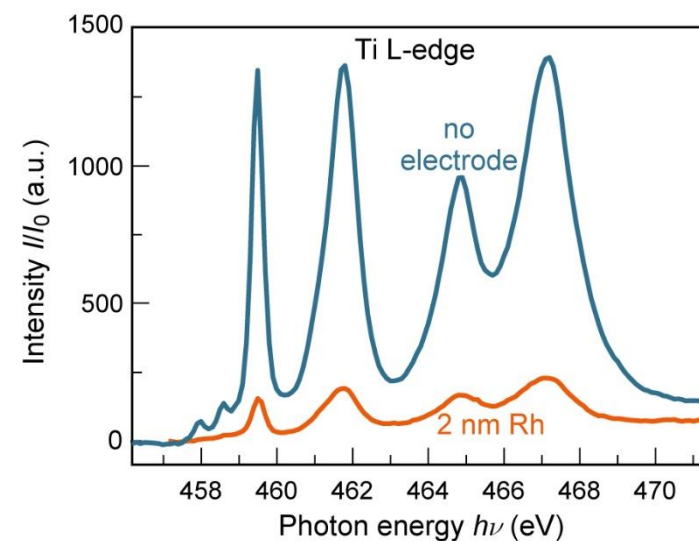


Muller, *Nature* **430** (2004)

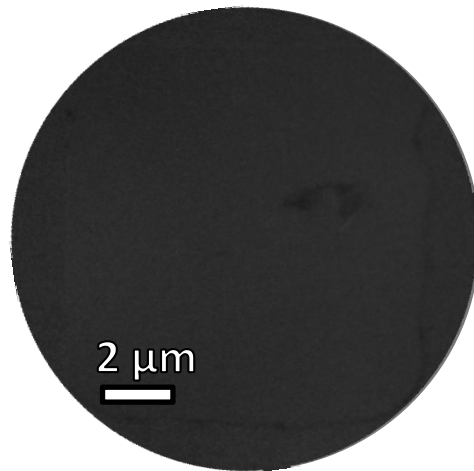


Photoelectron emission microscopy

- spatially resolved XPS and XAS
- composition sensitive
- valence state sensitive
- **surface sensitive**

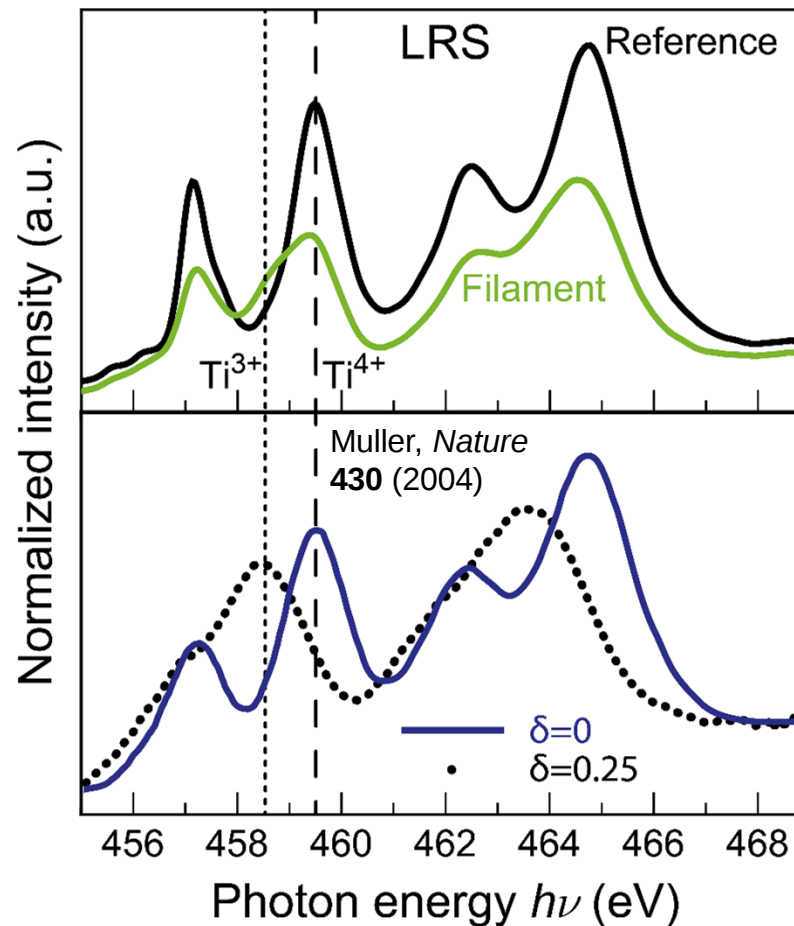


PEEM image stack

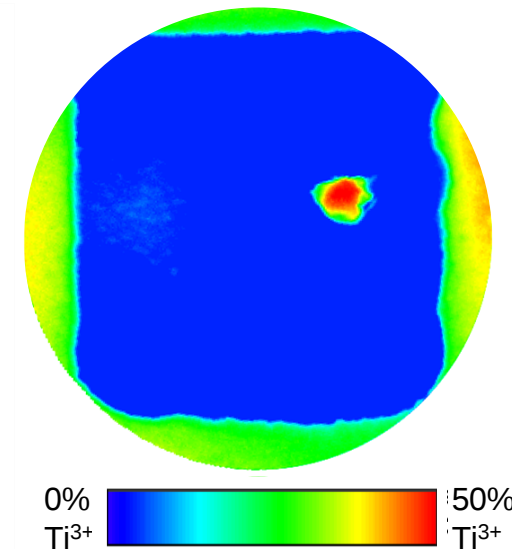


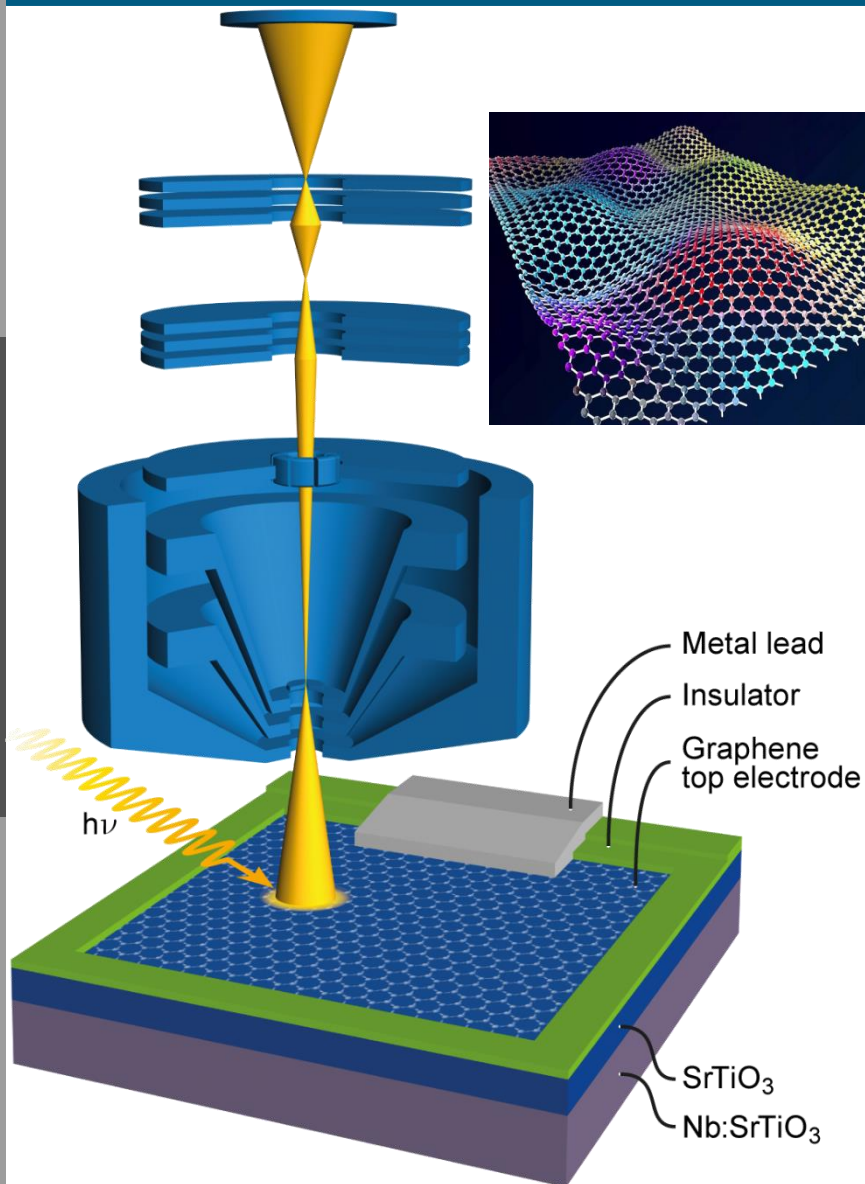
- Identification of switching filament
- LRS: Ti^{3+} filament in Ti^{4+} matrix
- ? Switching details

Ti L-edge spectra



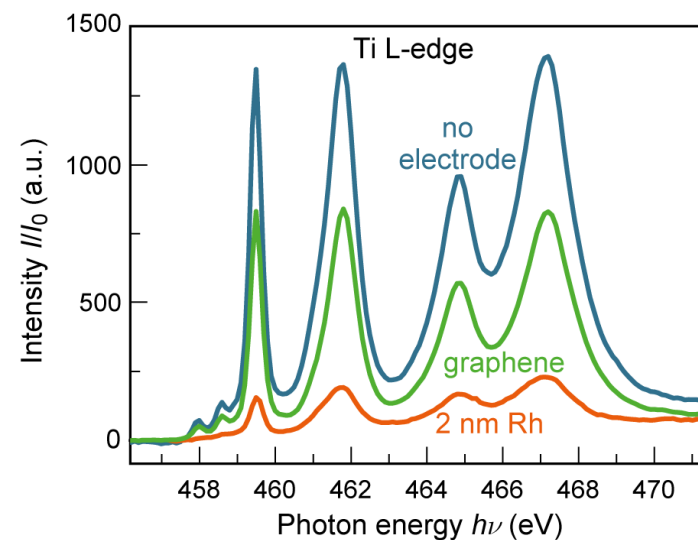
False color map





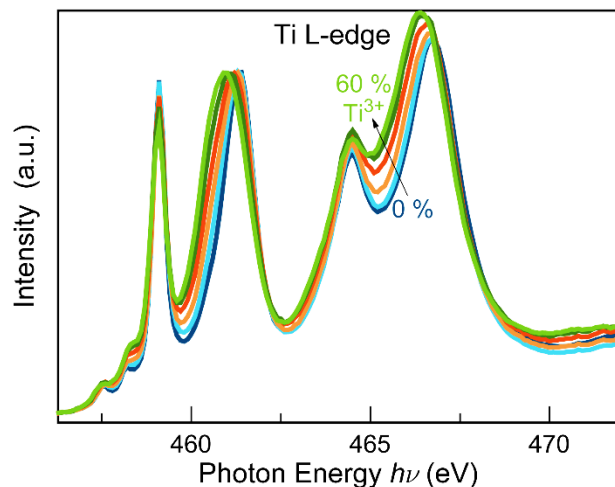
Photoelectron emission microscopy

- surface sensitivity:
need for ultra-thin electrode
- graphene is the ideal candidate
- excellent signal-to-noise ratio



Baeumer et al., Nat. Commun. 7 (2016)

graphene growth:
S. Rogers, M. Shim, University of Illinois

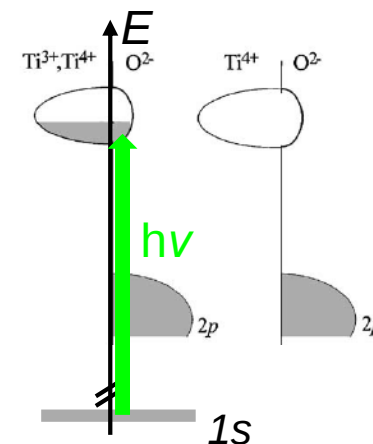
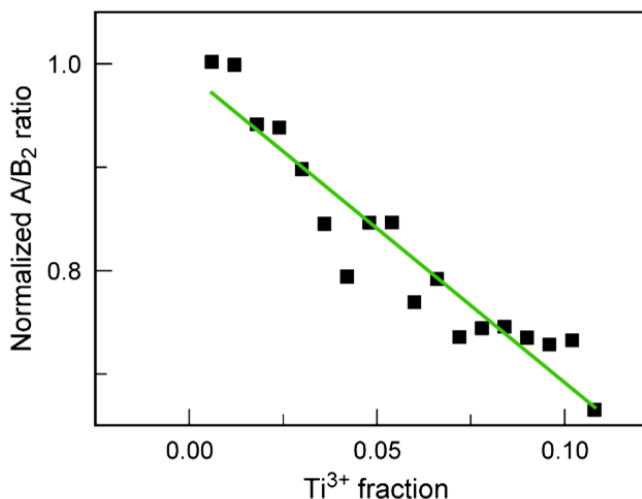
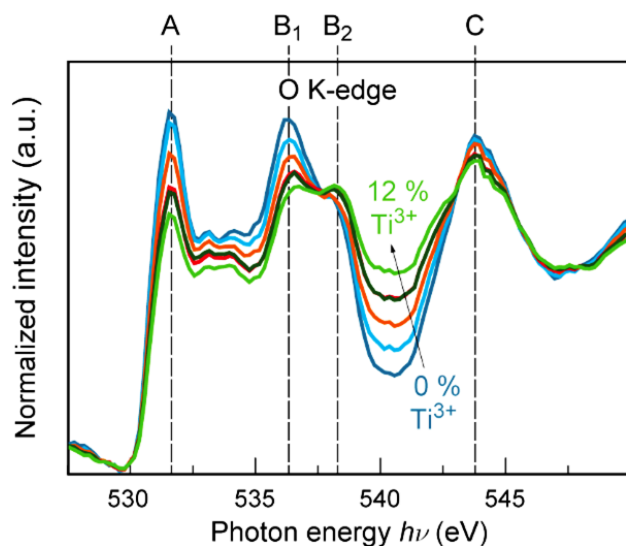


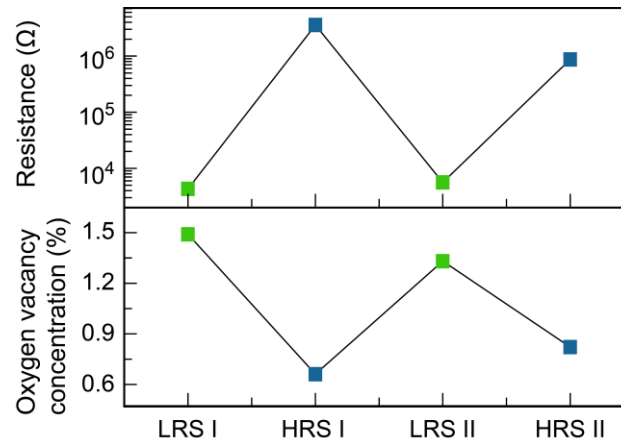
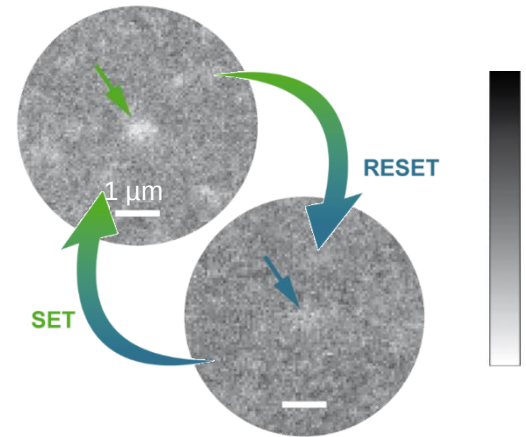
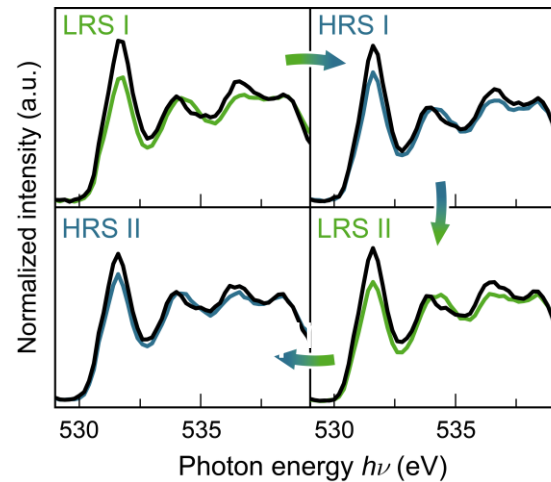
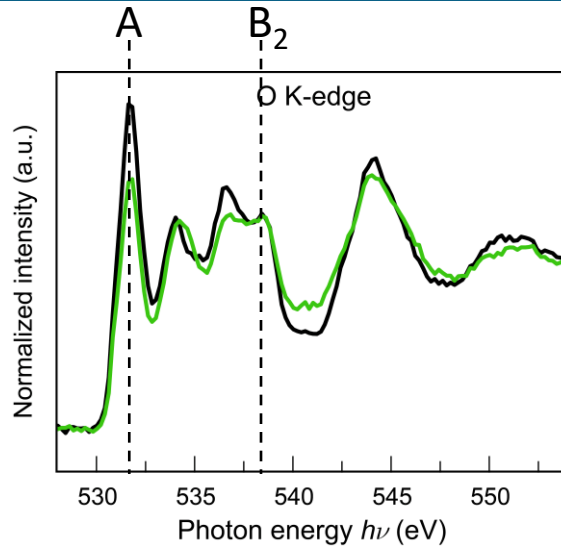
Ti L edge

- Large changes: significant spectral changes
- Subtle changes: spectral features hard to detect

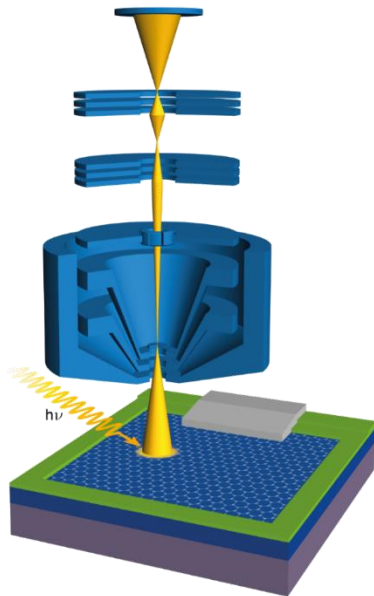
O K edge

- Subtle changes: O K-edge very sensitive
- Direct measure for electrons in conduction band



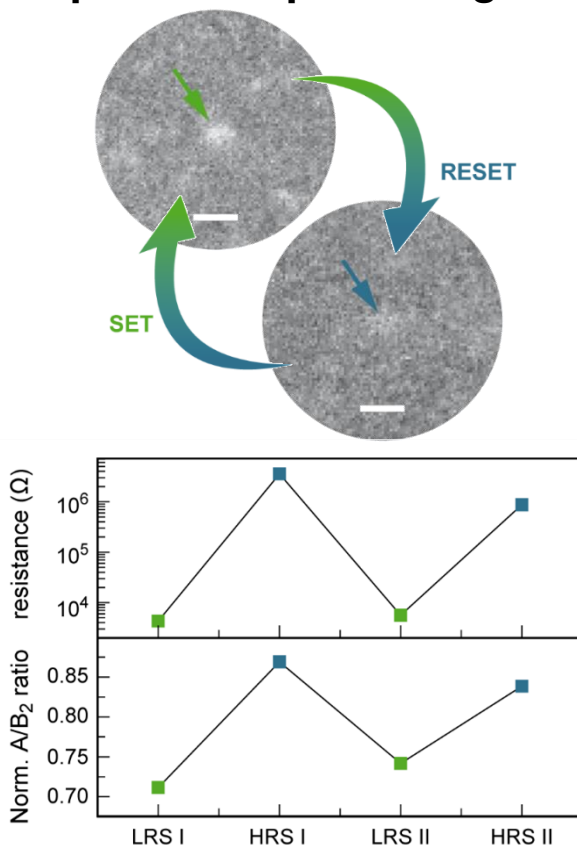


- Switching-induced modulation in oxygen vacancy concentration
- Variation by factor 2-3
- Agreement with resistance change
- Variation by 10^2 - 10^3

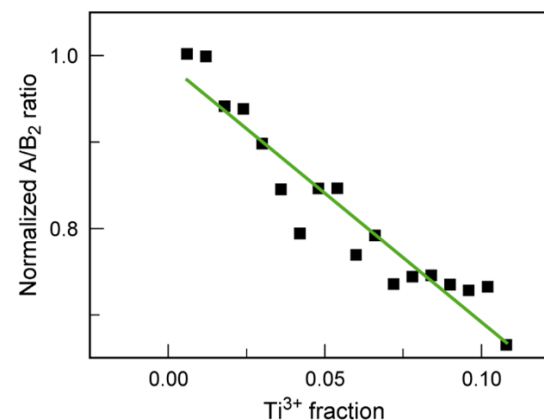


Baeumer, *Nat. Commun.* **7** (2016)

Spectroscopic change



Comparison with calibration



	LRS	HRS
N_{VO}	$3.35 \times 10^{20} \text{ cm}^{-3}$	$7.5 \times 10^{20} \text{ cm}^{-3}$
n	$1.5 \times 10^{21} \text{ cm}^{-3}$	$6.7 \times 10^{20} \text{ cm}^{-3}$



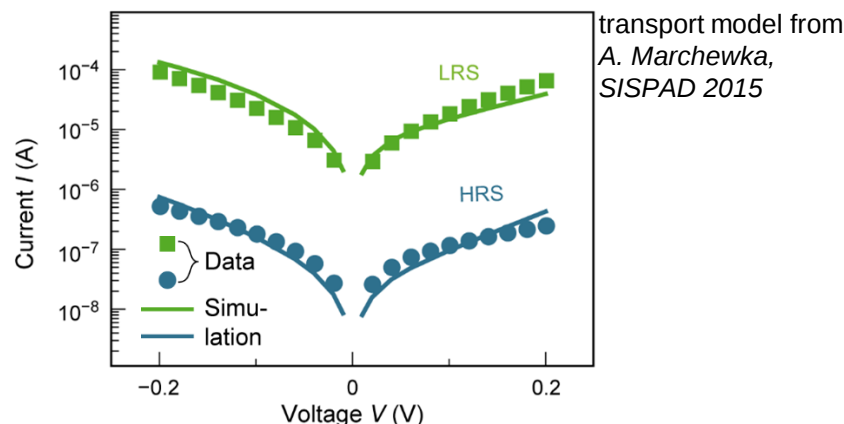
- ✓ Redox-induced carrier density modulations
- ✓ Variation by factor 2-3

- ✓ Agreement with resistance change
- ✓ Variation by 10^2 - 10^3

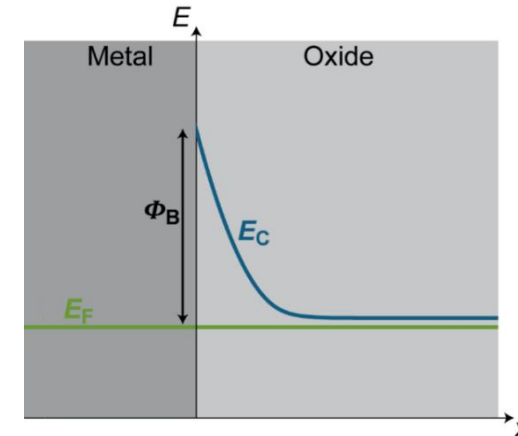
- experimental quantities:
resistance + vacancy concentration

	LRS	HRS
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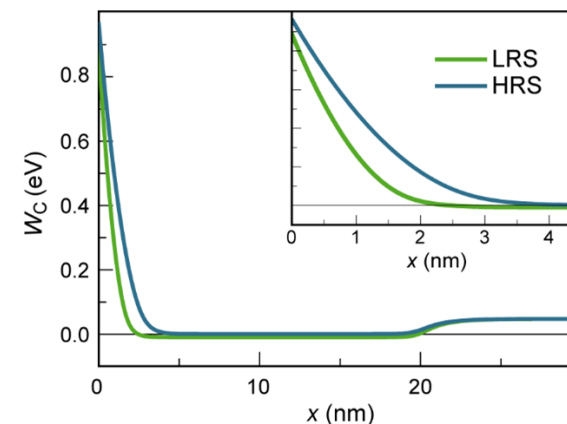
- transport model based on
experimental quantities



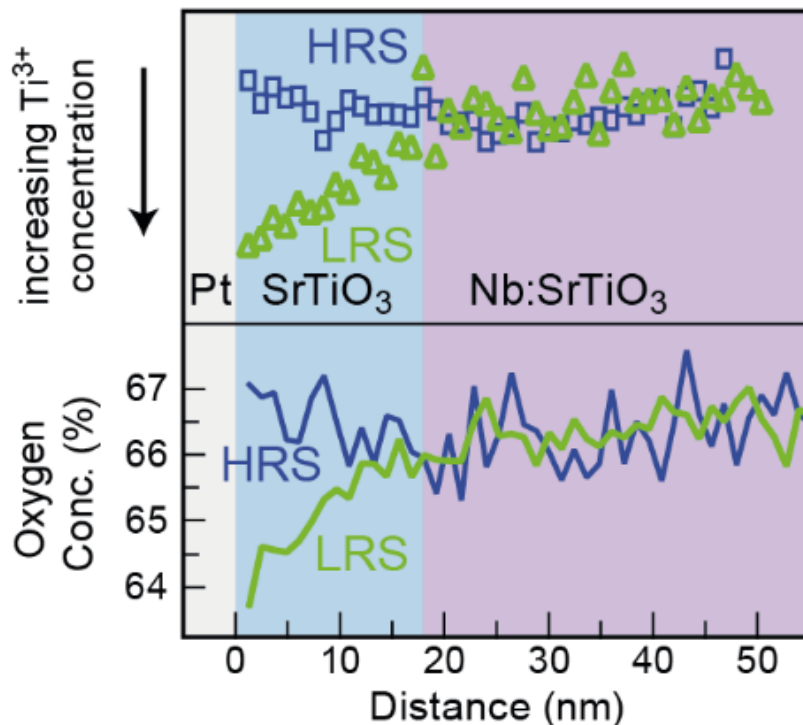
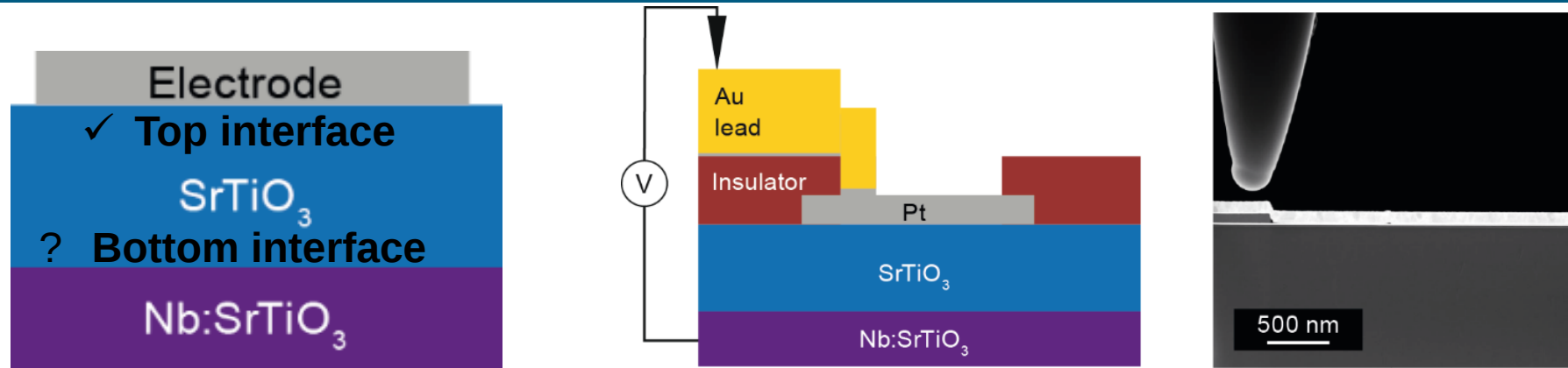
- understanding the device
resistance: A Schottky barrier



- oxygen vacancy variation causes
Schottky barrier modification



Baeumer, *Nat. Commun.* **7** (2016). **Simulation:** A. Marchwka & S. Menzel, RWTH Aachen & FZJ



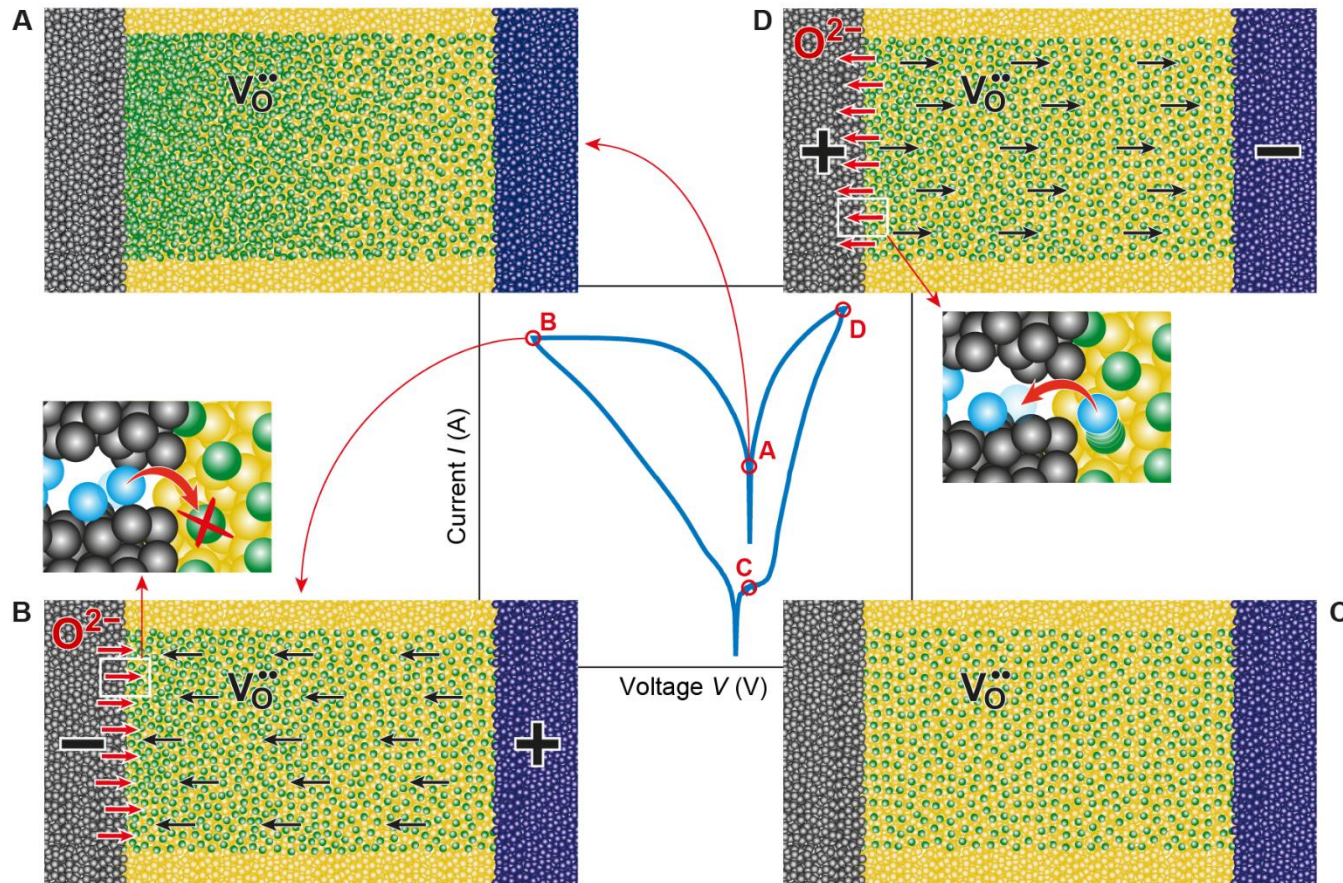
- ✓ *In operando* TEM clarifies switching details
- ✓ Concentration variation only at top interface
- ✓ Agreement with PEEM data
- ✓ LRS: decrease of the total oxygen concentration in the film
- ✓ LRS: Ti^{3+} gradient
- ✓ HRS: Nearly stoichiometric SrTiO_3

Cooper, Baeumer *et al.*, *Adv. Mater.* (accepted, 2017)

Oxygen evolution and reincorporation reaction: $2\text{Ti}^{4+} + \text{O}_\text{O} \leftrightarrow 2\text{Ti}^{3+} + \text{V}_\text{O}^{\bullet\bullet} + \frac{1}{2}\text{O}_2 \uparrow$

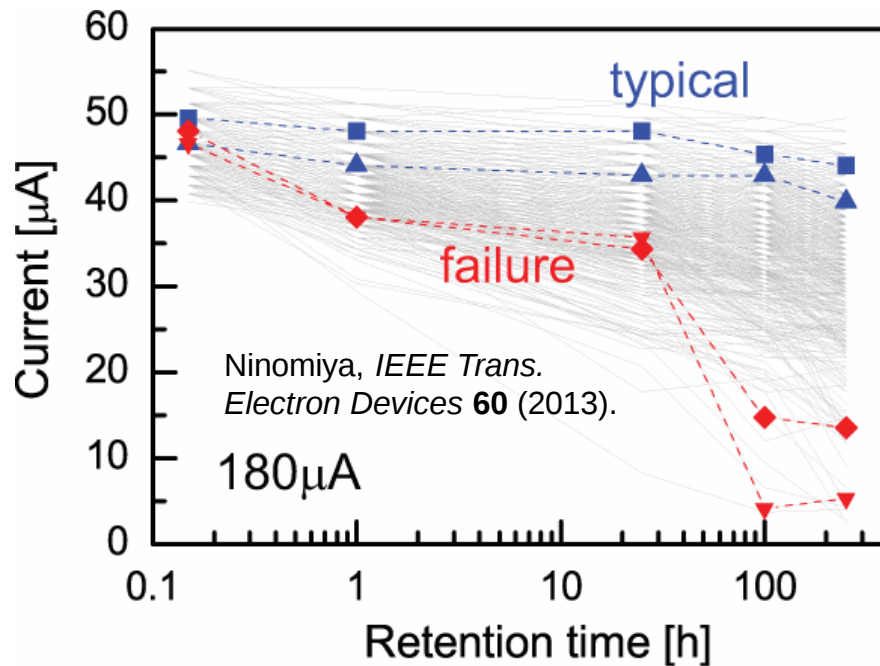
Set: left to right

Reset: right to left

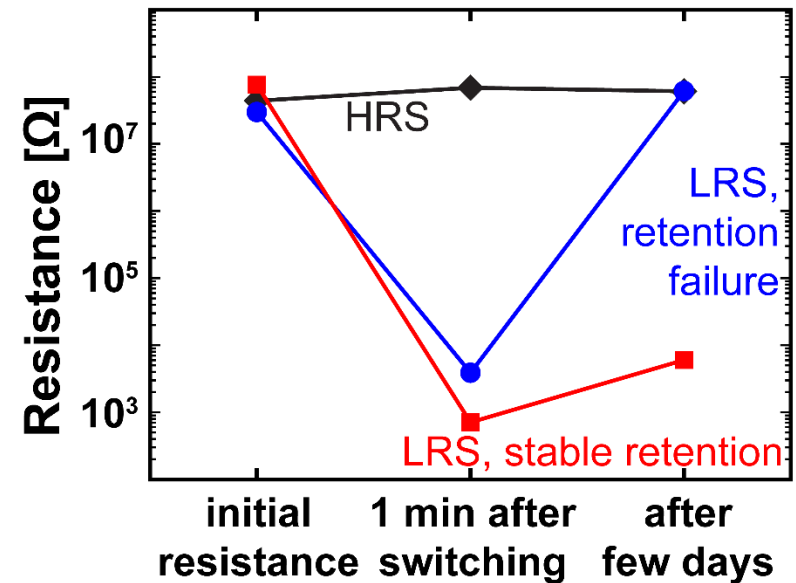
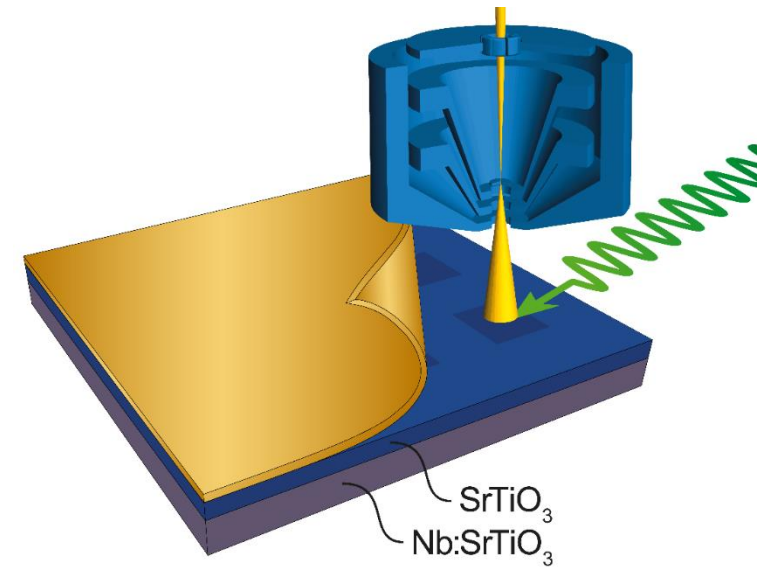


Cooper, Baeumer *et al.*, *Adv. Mater.* (accepted, 2017)

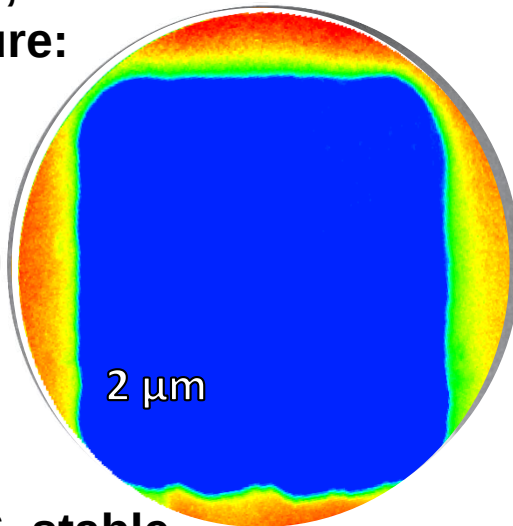
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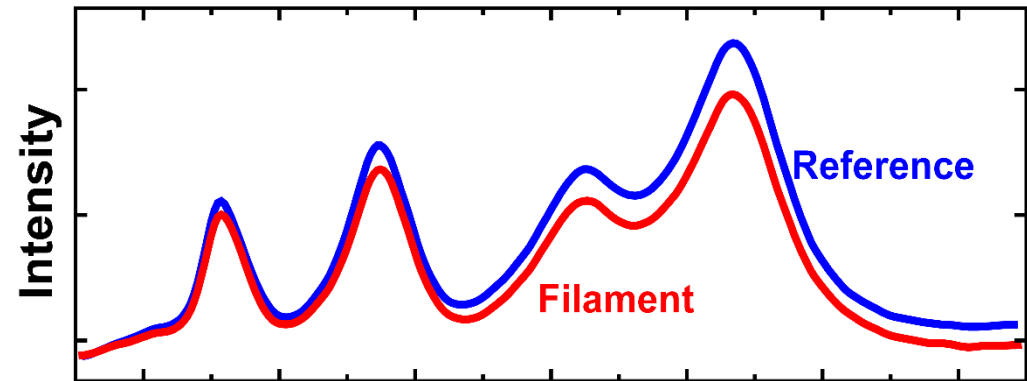
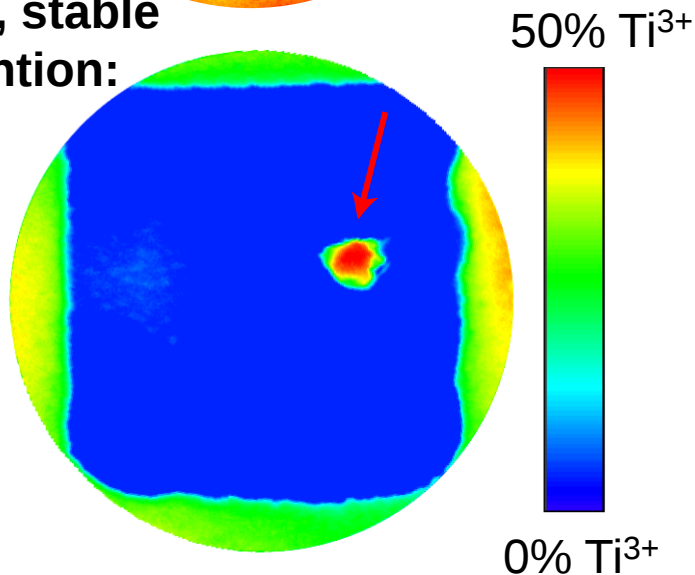
- ✓ Long retention for some devices
- ? Operation mechanism
- ? Failure mechanism
- ? Design rules



LRS, retention failure:

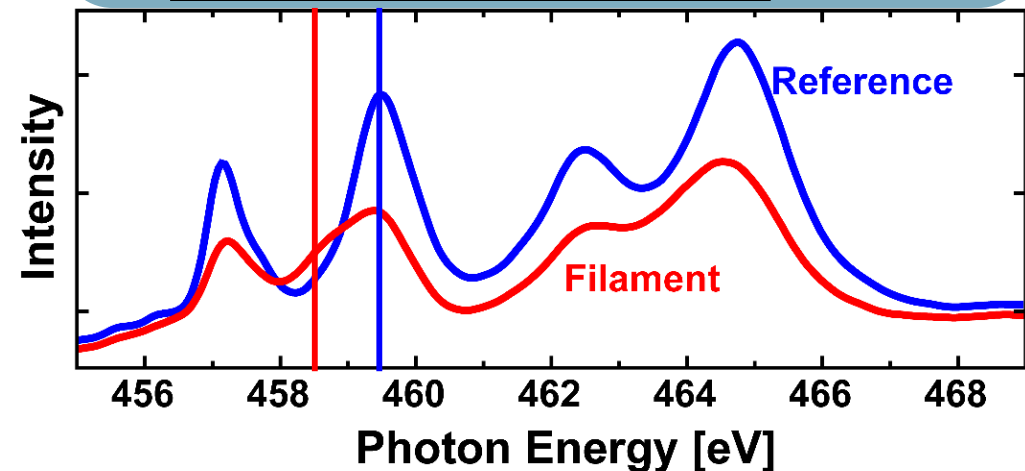


LRS, stable retention:

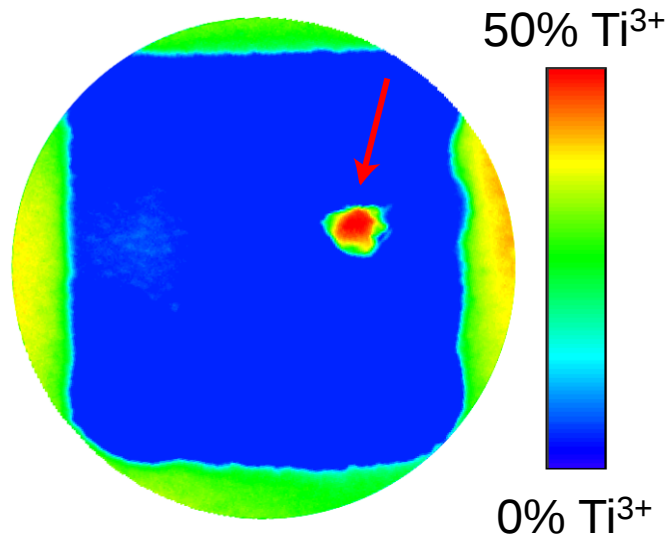


✓ Retention failure mechanism:
Re-oxidation of the switching filament

? Retention stabilization

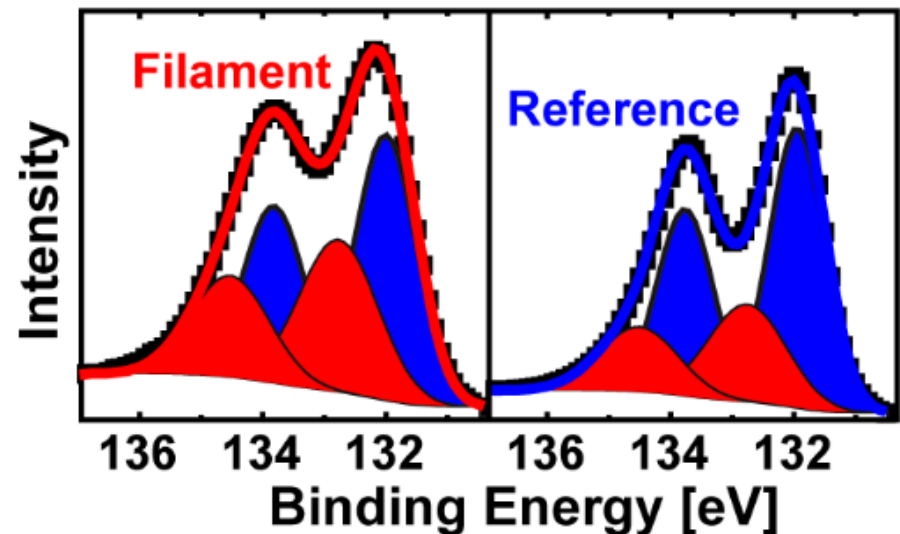
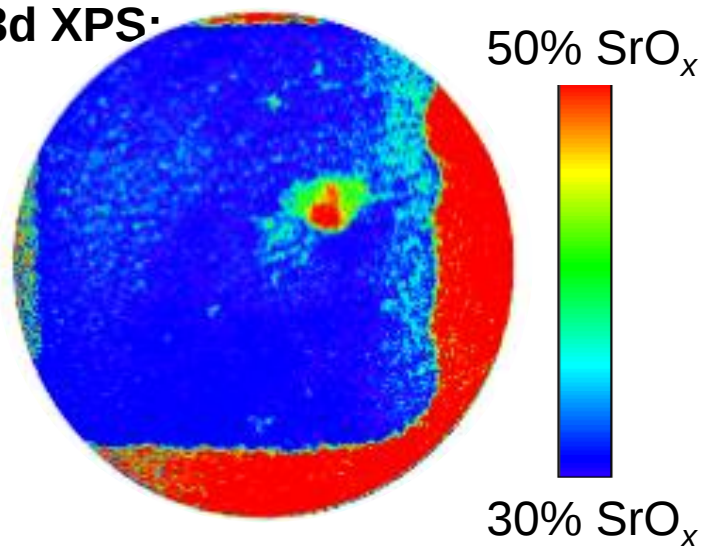


Ti valence state:



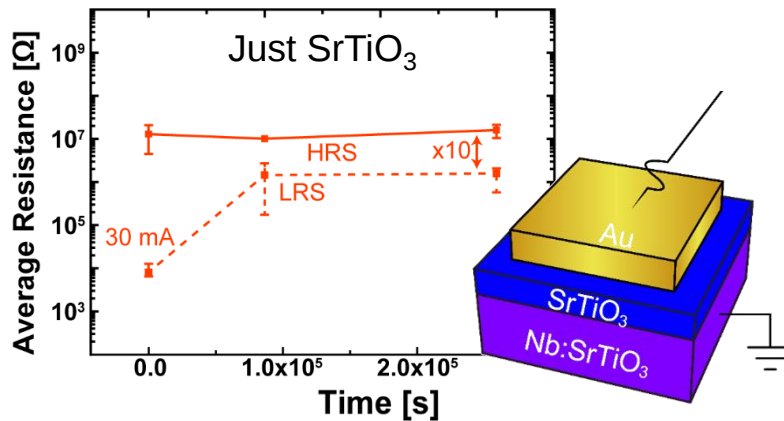
- ✓ Stable retention: Microscopic phase separation into Sr-deficient SrTiO_3 and SrO surface layer
- ? Side effect or origin of retention stabilization

Sr 3d XPS:



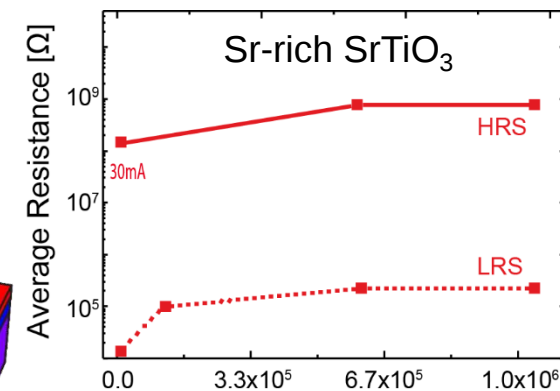
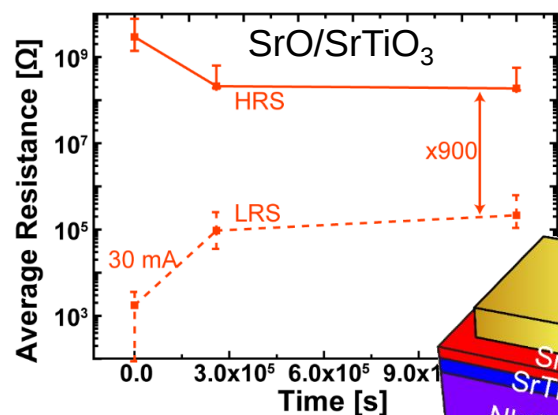
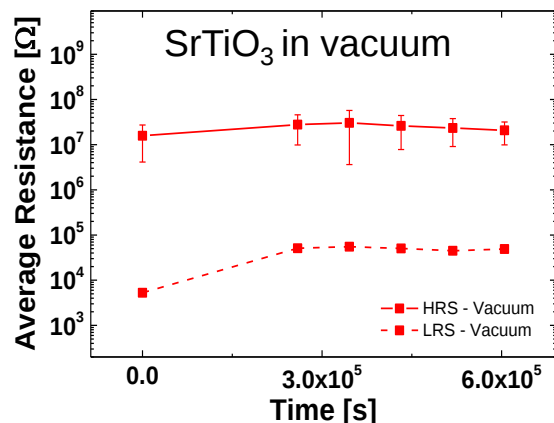
Baeumer et al., Nat. Commun. 6 (2015)

Stoichiometric SrTiO_3 : Retention failure



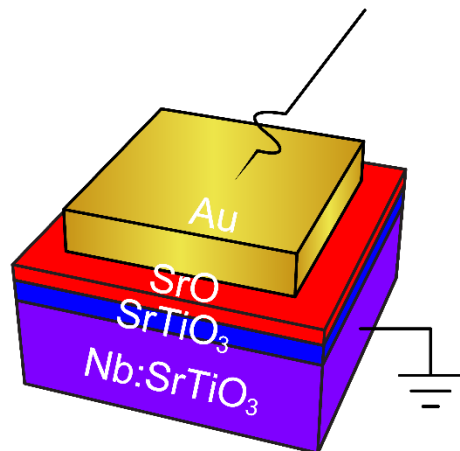
- ✓ $\text{SrO}/\text{SrTiO}_3$ interface inhibits re-oxidation
- ? SrO = Oxygen reservoir
- ? Role of oxygen diffusion coefficient

Operation in vacuum or SrO interlayer or Sr-rich SrTiO_3 : Retention stabilization

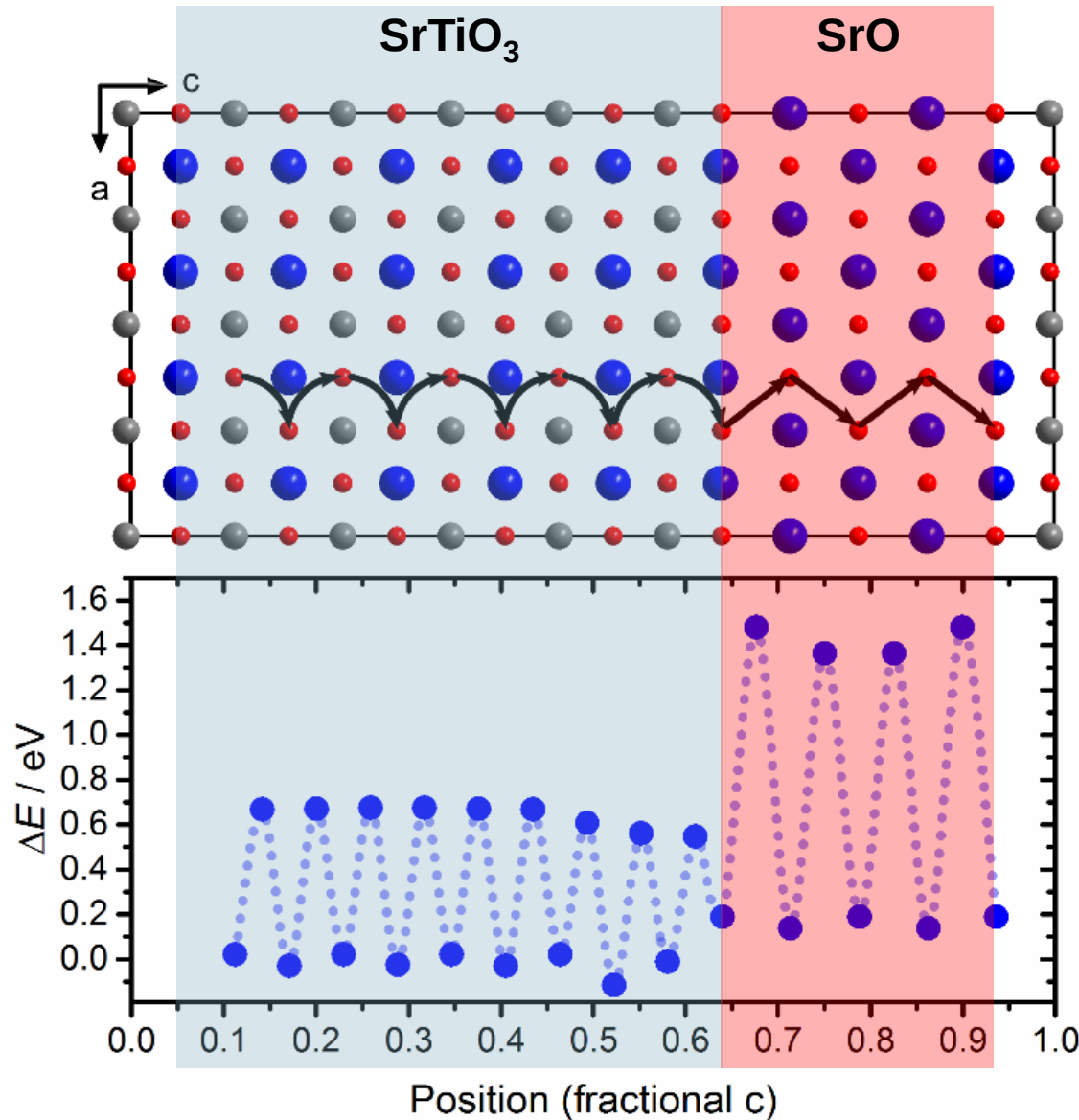


Baeumer et al., Nat. Commun. 6 (2015)

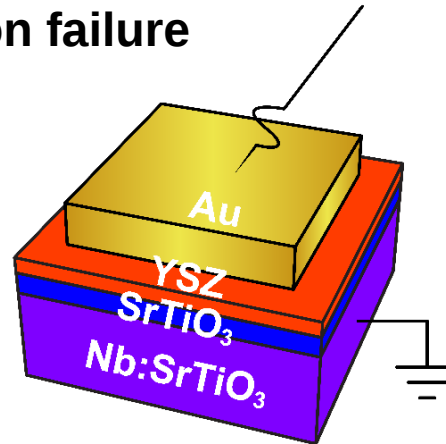
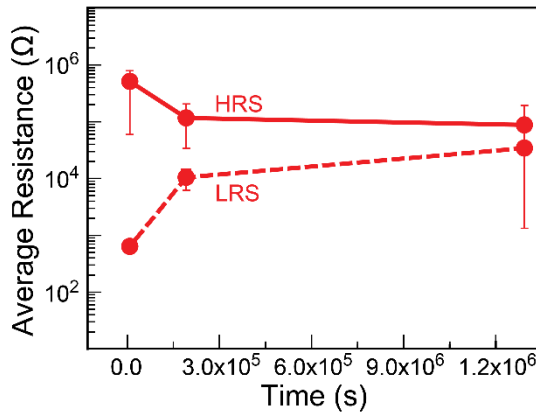
Raab et al., AIP Advances 5 (2015)



- ✓ SrO/SrTiO₃ interface inhibits re-oxidation
- ✓ Impeded oxygen diffusion in SrO

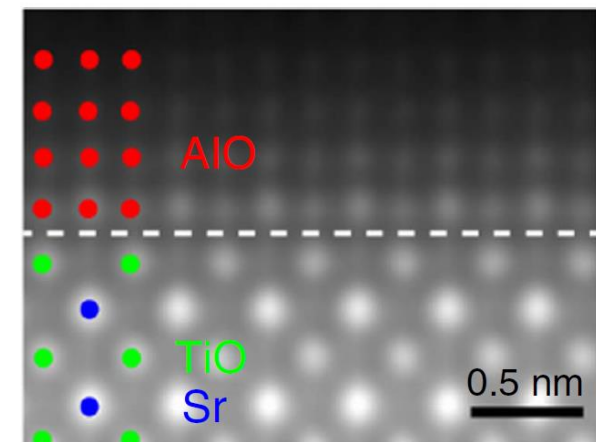
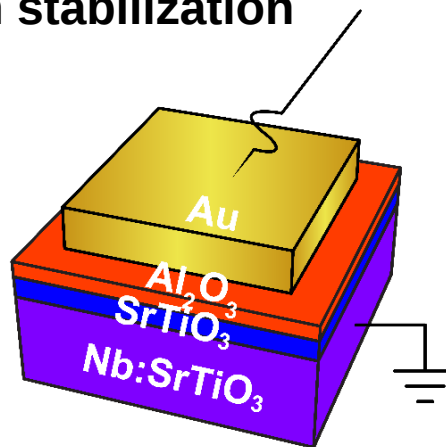
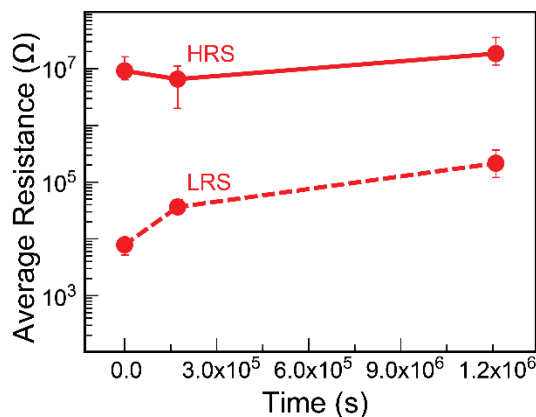


Enhanced oxygen migration: YSZ ($D(500\text{ K})=10^{-13}\text{ cm}^2\text{s}^{-1}$): Retention failure

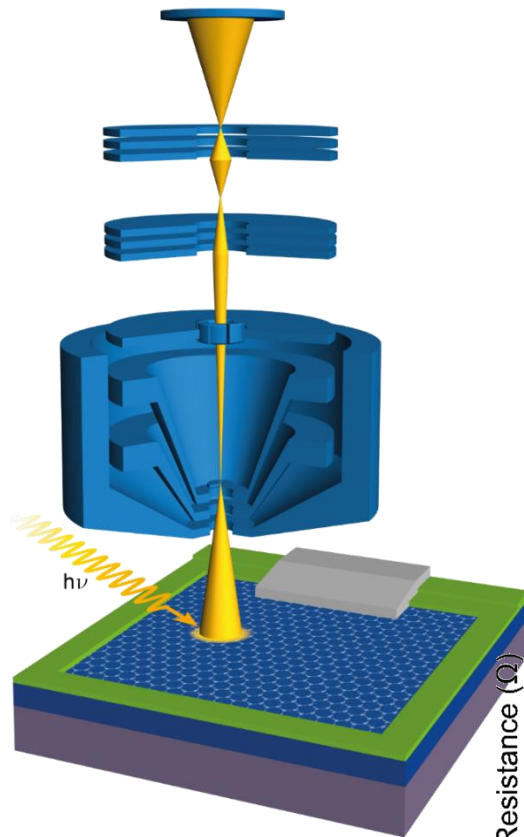


- ✓ Oxygen diffusion coefficient determines retention
- ✓ Al_2O_3 layer: good retention without structural changes

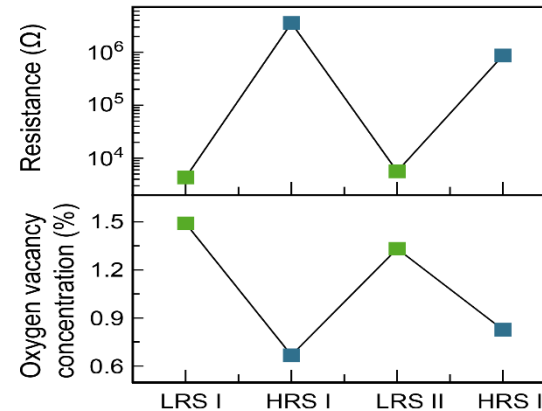
Inbited oxygen migration: Al_2O_3 $D(500\text{ K})=10^{-65}\text{ cm}^2\text{s}^{-1}$: Retention stabilization



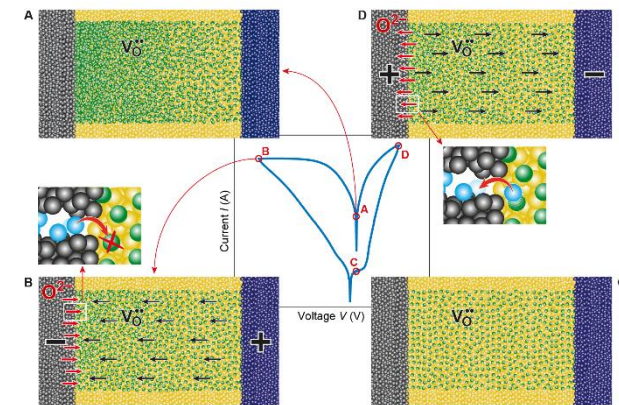
Spectromicroscopy: Post mortem & in-operando insights



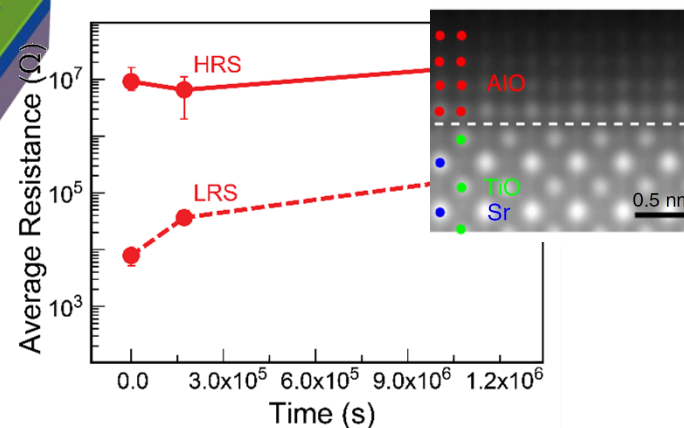
Quantitative evidence of local redox reaction



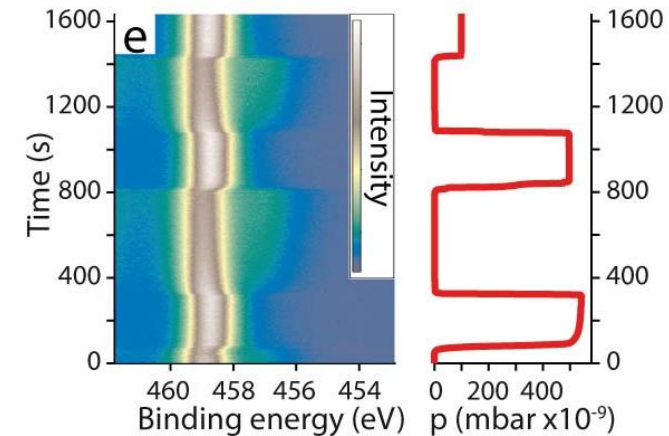
Mechanistic understanding of the switching process



Design rule: Prevent re-oxidation of filament



X-ray interaction: possible creation of defects (and second phases)



Jülich: Christoph Schmitz, Nicolas Raab, Philipp Müller, Thomas Heisig, Richard Valenta, Katharina Skaja, David Müller, Stephan Menzel, Claus Michael Schneider, Ilia Valov, Rainer Waser & Regina Dittmann

CEA/LETI: David Cooper

Bessy: Imtiaz Khan, Johanna Hackl & Slavomir Nemsak

Elettra: Vitaliy Feyer, Andrea Locatelli, Tefvik Onur Menten

RWTH: Camilla La Torre, Astrid Marchewka & Stephan Menzel

UIUC: Steven Rogers & Moonsub Shim

Thank you for your attention!

Funded by:

